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APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.
10/579,056	05/11/2006	David R McMurtry	127926	6323
25944 OLIFF & BERI	7590 09/04/200 RIDGE, PLC	EXAMINER		
P.O. BOX 320850			DAVIS, OCTAVIA L	
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			09/04/2008	PAPER

Please find below and/or attached an Office communication concerning this application or proceeding.

The time period for reply, if any, is set in the attached communication.

	Application No.	Applicant(s)	
	10/579,056	MCMURTRY ET AL.	
Office Action Summary	Examiner	Art Unit	
	OCTAVIA DAVIS	2855	
The MAILING DATE of this communication a Period for Reply	appears on the cover sheet wi	h the correspondence address	
A SHORTENED STATUTORY PERIOD FOR REF WHICHEVER IS LONGER, FROM THE MAILING  - Extensions of time may be available under the provisions of 37 CFR after SIX (6) MONTHS from the mailing date of this communication.  - If NO period for reply is specified above, the maximum statutory perion.  - Failure to reply within the set or extended period for reply will, by stat Any reply received by the Office later than three months after the may earned patent term adjustment. See 37 CFR 1.704(b).	DATE OF THIS COMMUNIC 1.136(a). In no event, however, may a re- od will apply and will expire SIX (6) MON tute, cause the application to become AB	CATION.  ply be timely filed  THS from the mailing date of this communication.  ANDONED (35 U.S.C. § 133).	
Status			
Responsive to communication(s) filed on 5/2      This action is <b>FINAL</b> . 2b) ☐ TH      Since this application is in condition for allow closed in accordance with the practice unde	his action is non-final. vance except for formal matte	·	
Disposition of Claims			
4) ☐ Claim(s) 1-18 is/are pending in the application 4a) Of the above claim(s) is/are withd 5) ☐ Claim(s) is/are allowed. 6) ☐ Claim(s) 1-18 is/are rejected. 7) ☐ Claim(s) is/are objected to. 8) ☐ Claim(s) are subject to restriction and	rawn from consideration.		
9)☐ The specification is objected to by the Exami	ner.		
10) The drawing(s) filed on is/are: a) a  Applicant may not request that any objection to the Replacement drawing sheet(s) including the correct and the	ne drawing(s) be held in abeyan ection is required if the drawing(	ce. See 37 CFR 1.85(a). s) is objected to. See 37 CFR 1.121(d).	
Priority under 35 U.S.C. § 119			
12) Acknowledgment is made of a claim for foreign a) All b) Some * c) None of:  1. Certified copies of the priority docume 2. Certified copies of the priority docume 3. Copies of the certified copies of the priority docume application from the International Bure * See the attached detailed Office action for a li	ents have been received. ents have been received in A riority documents have been eau (PCT Rule 17.2(a)).	oplication No received in this National Stage	
Attachment(s)  1) Notice of References Cited (PTO-892)  2) Notice of Draftsperson's Patent Drawing Review (PTO-948)  3) Information Disclosure Statement(s) (PTO/SB/08)  Paper No(s)/Mail Date	Paper No(s	ummary (PTO-413) )/Mail Date formal Patent Application _·	

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#### **DETAILED ACTION**

#### Specification

1. The following guidelines illustrate the preferred layout for the specification of a utility application. These guidelines are suggested for the applicant's use.

### Arrangement of the Specification

As provided in 37 CFR 1.77(b), the specification of a utility application should include the following sections in order. Each of the lettered items should appear in upper case, without underlining or bold type, as a section heading. If no text follows the section heading, the phrase "Not Applicable" should follow the section heading:

- (a) TITLE OF THE INVENTION.
- (b) CROSS-REFERENCE TO RELATED APPLICATIONS.
- (c) STATEMENT REGARDING FEDERALLY SPONSORED RESEARCH OR DEVELOPMENT.
- (d) THE NAMES OF THE PARTIES TO A JOINT RESEARCH AGREEMENT.
- (e) INCORPORATION-BY-REFERENCE OF MATERIAL SUBMITTED ON A COMPACT DISC.
- (f) BACKGROUND OF THE INVENTION.
  - (1) Field of the Invention.
  - (2) Description of Related Art including information disclosed under 37 CFR 1.97 and 1.98.
- (g) BRIEF SUMMARY OF THE INVENTION.
- (h) BRIEF DESCRIPTION OF THE SEVERAL VIEWS OF THE DRAWING(S).
- (i) DETAILED DESCRIPTION OF THE INVENTION.
- (i) CLAIM OR CLAIMS (commencing on a separate sheet).
- (k) ABSTRACT OF THE DISCLOSURE (commencing on a separate sheet).
- (I) SEQUENCE LISTING (See MPEP § 2424 and 37 CFR 1.821-1.825. A "Sequence Listing" is required on paper if the application discloses a nucleotide or amino acid sequence as defined in 37 CFR 1.821(a) and if the required "Sequence Listing" is not submitted as an electronic document on compact disc).

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#### Claim Rejections - 35 USC § 103

2. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

- (a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.
- 3. Claims 1, 4, 6, 9 15 and 18 are rejected under 35 U.S.C. 103(a) as being unpatentable over Lotze et al (6,591,208) in view of Lotze et al (6,546,643).

Regarding claims 1, 4 and 18, Lotze et al disclose a correction method for a coordinate measuring apparatus comprising determining the stiffness of a coordinate positioning apparatus (See Col. 4, lines 65 - 67 and Col. 7, lines 43 - 45), determining the load factor applied by a probe head 9 at any particular instant (See Col. 3, lines 43 - 50 and Col. 4, lines 10 - 13) and a processor that determines the measurement error at the surface sensing device 13 caused by the load using the stiffness and the load factor, wherein the device is a contact probe (See Col. 3, lines 55 - 65 and Col. 4, lines 62 - 65) but does not disclose that the probe head is an articulating probe head and determining a load or one or more factors relating to the load applied by a motion of the articulating probe head about at least one axis. However, Lotze et al disclose an articulating device for the probe head of a coordinate measuring apparatus comprising a probe head 4 that is mounted in a receptacle of an articulating device that is attached to a measuring apparatus, the measured values from the measuring apparatus being recorded by a coordinate measuring apparatus and corrected in a correcting unit 2 (See Col. 3, lines 56 - 60 and Col. 4, lines 10 - 23) and determining a measurement error caused by a load (See Col. 6, lines 15 - 21 and 54 - 65 and Col. 7, lines 16 - 20).

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Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify Lotze et al according to the teachings of Lotze et al for the purpose of, advantageously providing an articulating device for a probe head of a coordinate measuring apparatus in which the bending that is caused by the probe configuration can be corrected in a n improved manner (See Lotze et al, Col. 2, lines 31 - 33).

Regarding claim 6, in Lotze et al, the stiffness is determined by applying a load to the apparatus and measuring the deflection (See Col. 3, lines 43 - 50 and Col. 4, lines 6 - 13) and by measuring an object of known dimensions 5 while measuring the load.

Regarding claims 9 and 10, in Lotze et al, the contact probe is positioned so that the stylus or probe pin 13 is in contact with the surface of an object of known dimensions 5 and measurement readings of the surface are taken when different probe forces are applied (See Col. 3, lines 64 - 67).

Regarding claims 11 - 14, in Lotze et al, an accelerometer is used to determine the load factor and the one or more factors which relate to the load is determined from system variables of the apparatus (See Col. 4, lines 58 - 61).

Regarding claim 15, in Lotze et al, the offset of the measurement path is determined of the surface sensing device from a datum point, wherein this offset is used in calculating the measurement error (See Col. 11, lines 38 – 46).

#### Claim Rejections - 35 USC § 103

4. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

<sup>(</sup>a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary

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skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

5. Claims 2, 3, 16 and 17 are rejected under 35 U.S.C. 103(a) as being unpatentable over Lotze et al (208') and Lotze et al (643'), as applied to claims 1, 4, 6, 9 – 15 and 18 above, and further in view of McMurtry et al (5,152,072).

Regarding claims 2, 3, 16 and 17, Lotze et al and Lotze et al disclose all of the limitations of these claims except that the load comprises a torque and a linear force, determining the offset of the measurement path of the surface sensing device from a datum point, wherein this offset is used in calculating the measurement error, the measurement error being substantially proportional to an equation including L which is the distance from a datum point in the articulating probe head to the measurement path of the surface sensing device, q which is the angle between the surface sensing device and an axis normal to the axis of a structure onto which the articulating probe head is mounted and an angular deflection of the mount and L being the distance between the tip of the surface sensing device and the centre of rotation. However, McMurtry et al disclose a surface sensing device comprising a load that includes a torque and a linear force (See Col. 2, lines 27 – 29, Col. 3, lines 7 – 11 and Col. 5, lines 31 - 37), the measurement error being substantially proportional to an equation that includes distance, angle and deflection and the distance being between the tip of the surface sensing device and the center of rotation (See Col. 2, lines 16 – 21 and 36 – 41 and Col. 3, lines 19 – 29, See Fig. 1).

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify Lotze et al and Lotze et al according to the teachings of McMurtry et al for the purpose of, advantageously providing a support structure for an elongate surface-sensing

stylus useful in obtaining continuous data on the position of a surface (SeeMcMurtry et al, Col. 1, lines 38 - 40).

Claim Rejections - 35 USC § 103

6. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness

rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the

subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the

invention was made.

7. Claim 5 is rejected under 35 U.S.C. 103(a) as being unpatentable over Lotze et al (208') and

Lotze e al (643), as applied to claims 1, 4, 6, 9 – 15 and 18 above, and further in view of Nai

(6,568,242).

Regarding claim 5, Lotze et al and Lotze et al disclose all of the limitations of these claims

except that the surface sensing device is a non-contact probe. However, Nai discloses a system for

reducing effects of acceleration induced deflections on measurements made by a machine using a

probe comprising a scanning probe 20 that is non-contacting (See Col. 3, lines 46 - 51).

Therefore, it would have been obvious to one of ordinary skill in the art at the time the

invention was made to modify Lotze et al and Lotze et al according to the teachings of Nai for the

purpose of, advantageously reducing measuring errors made by a machine using different types of

probes (See Col. 2, lines 60 - 63).

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## Claim Rejections - 35 USC § 103

8. The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

9. Claims 7 and 8 are rejected under 35 U.S.C. 103(a) as being unpatentable over Lotze et al (208') and Lotze et al (643'), as applied to claims 1, 4, 6, 9 – 15 and 18 above, and further in view of Bernhardt et al (5,594,668).

Regarding claims 7 and 8, Lotze et al and Lotze et al disclose all of the limitations of these claims except that the deflection is determined from the difference between the known and measured dimensions of the object and the known dimensions of the object are determined by measuring it at slow speed. However, Bernhardt et al disclose a method for correcting coordinate measurement on workpieces based on bending characteristics comprising determining the stiffness from the differences between measured values of a stiffness probe and of a probe to be calibrated as a result of reactive forces occurring during difference accelerations or velocities (See Col. 7, lines 23 - 39).

Therefore, it would have been obvious to one of ordinary skill in the art at the time the invention was made to modify Lotze et al and Lotze et al according to the teachings of Bernhardt et al for the purpose of, advantageously providing a method for correcting measuring errors in a coordinate measuring machine to reduce the measuring uncertainty of existing coordinate measuring

machines and to permit coordinate measuring machines to be built with a lighter structure in the future (See Bernhardt et al, Col. 2, lines 48 - 55).

# Response to Arguments

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10. Applicant's arguments with respect to these claims have been considered but are moot in view of the new grounds of rejection.

#### Conclusion

11. The prior art made of record and not relied upon is considered pertinent to applicant's disclosure.

Vander Wal, III (5,430,948) discloses a coordinate measuring machine certification system.

121. Any inquiry concerning this communication or earlier communications from the examiner should be directed to Octavia Davis whose telephone number is 571-272-2176. The examiner can normally be reached on Mon through Thurs from 9 to 5. The examiner can also be reached on alternate Fridays.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Edward Lefkowitz, can be reached on 571-272-2180. The fax phone number for the organization where this application or proceeding is assigned is 571-273-8300.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system,

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see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

/Edward Lefkowitz/

Supervisory Patent Examiner, Art Unit 2855

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